



Docket No.:0756-7197  
IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

Koichiro TANAKA

)

Serial No. 10/664,916

) Group Art Unit: 1765

Filed: September 22, 2003

) Examiner: R. Kunemund

For: BEAM HOMOGENIZER AND LASER

)

IRRADIATION APPARATUS AND METHOD OF

MANUFACTURING SEMICONDUCTOR

DEVICE

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
The United States Postal Service with sufficient postage as First  
Class Mail in an envelope addressed to: Commissioner for Patents,  
P. O. Box 1450, Alexandria VA 22313-1450, on February 22, 2005

Eric J. Robinson

**REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

  
Eric J. Robinson

Reg. No. 38,285

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